

Reappraising the Need for Bulk Heterojunctions in Polymer-Fullerene Photovoltaics: The Role of Carrier Transport in All-Solution-Processed P3HT:PCBM Bilayer Solar Cells

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Reappraising the Need for Bulk Heterojunctions in Polymer-Fullerene Photovoltaics: The Role of Carrier Transport in All-Solution-Processed P3HT:PCBM Bilayer Solar Cells

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20 **Abstract:** The most efficient organic solar cells produced to date are bulk heterojunction (BHJ)
21 photovoltaic devices based on blends of semiconducting polymers such as poly(3-
22 hexylthiophene-2,5-diyl) (P3HT) with fullerene derivatives such as [6,6]-penyl-C₆₁-butyric-acid-
23 methyl-ester (PCBM). The need for blending the two components is based on the idea that the
24 exciton diffusion length in polymers like P3HT is only ~10 nm, so that the polymer and fullerene
25 components must be mixed on this length scale to efficiently split the excitons into charge
26 carriers. In this paper, we show that the BHJ geometry is not necessary for high efficiency, and
27 that all-solution-processed P3HT/PCBM bilayer solar cells can be nearly as efficient as BHJ
28 solar cells fabricated from the same materials. We demonstrate that *o*-dichlorobenzene (ODCB)
29 and dichloromethane serve nicely as a pair of orthogonal solvents from which sequential layers
30 of P3HT and PCBM, respectively, can be spin-cast. Atomic force microscopy, various optical
31 spectroscopies and electron microscopy all demonstrate that the act of spin-coating the PCBM
32 overlayer does not affect the morphology of the P3HT underlayer, so that our spin-cast
33 P3HT/PCBM bilayers have a well-defined planar interface. Our fluorescence quenching
34 experiments find that there is still significant exciton splitting in P3HT/PCBM bilayers even
35 when the P3HT layer is quite thick. When we fabricated photovoltaic devices from these
36 bilayers, we obtained photovoltaic power conversion efficiencies in excess of 3.5%. Part of the
37 reason for this high efficiency is that we were able to separately optimize the roles of each
38 component of the bilayer; for example, we found that thermal annealing has relatively little
39 effect on the nature of P3HT layers spin-cast from ODCB but that it significantly increases the
40 crystallinity and thus the mobility of electrons through PCBM. Because the carriers in bilayer
41 devices are generated at the planar P3HT/PCBM interface, we also were able to systematically
42 vary the distance the carriers have to travel to be extracted at the electrodes by changing the layer
43 thicknesses without altering the bulk mobility of either component or the nature of the interfaces.
44 We found that devices have the best fill-factors when the transit times of electrons and holes
45 through the two layers are roughly balanced. In particular, we found that the most efficient
46 devices are made with P3HT layers that are ~4 times thicker than the PCBM layers,
47 demonstrating that it is the conduction and extraction of electrons through the fullerene that
48 ultimately limits the performance of both bilayer and BHJ devices based on the P3HT/PCBM
49 material combination. Overall, we believe that polymer-fullerene bilayers provides several
50 advantages over BHJ devices, including reduced carrier recombination and a much better degree
51 of control over the properties of the individual components and interfaces during device
52 fabrication.
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I. INTRODUCTION

Thin film photovoltaics (PVs) based on blends of conjugated polymers as electron donors and fullerenes as electron acceptors have been the subject of intense research owing to the ease with which they can be fabricated into inexpensive plastic solar cells.¹⁻³ When blended together, conjugated polymers and fullerenes phase segregate on nanometer length scales, producing a bicontinuous interpenetrating network of the polymer and fullerene components, which is often referred to as a bulk heterojunction (BHJ).^{4,5} Light incident on BHJ solar cells is primarily absorbed by the π -conjugated polymer, leading to the creation of strongly-bound excitons. Literature reports have estimated that excitons can diffuse only over distances of ~ 10 nm.^{6,7} If the polymer and fullerene components are phase segregated on the same length scale as excitons can move, then essentially every exciton can diffuse to within charge-transfer range of a fullerene molecule during its lifetime, resulting in exciton splitting and the formation of polaron pairs⁸⁻¹⁰ with near unit quantum yield.¹¹⁻¹³ These Coulombically-bound charge pairs are then separated due to a combination of electric potential and concentration gradients¹⁴ and eventually collected at the electrodes to produce a photocurrent in the external circuit. To date, BHJ solar cells based on the combination of the regioregular polymer poly(3-hexylthiophene-2,5-diyl) (P3HT) and the fullerene derivative [6,6]-phenyl-C61-butyric-acid-methyl-ester (PCBM) have reached power conversion efficiencies exceeding $\sim 5\%$,¹⁵⁻¹⁷ with even higher efficiencies obtained for devices based on redder-absorbing conjugated polymers and/or fullerene derivatives.¹⁸

Even though polymer-based BHJ solar cells have achieved quite respectable power conversion efficiencies, questions still remain regarding the fundamental processes that ultimately limit device performance. For example, there is still significant argument as to whether the mobility of holes in the polymer component or electrons in the fullerene component of the BHJ cell is what limits device performance.¹⁹⁻²³ It is well known that thermal annealing improves the power conversion efficiency of polymer-based BHJ photovoltaics, but the effects of annealing on carrier mobility in the individual BHJ components and the way annealing affects the degree of phase segregation also have been the subject of debate.^{19,20} Finally, because BHJs have a complex, difficult-to-characterize nanoscale morphology,^{15,24-28} there have been no systematic studies investigating how the transit times for electrons and holes on the two

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3 components affect the general shape of the device current-voltage response under solar
4 illumination.
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7 In this paper, we address these fundamental issues in polymer-fullerene photovoltaic
8 systems by removing the complexity associated with the nanoscale architecture of BHJs and
9 focusing on fully solution-cast planar P3HT:PCBM bilayer solar cells. Although the bilayer
10 geometry has not been popular for polymer-based solar cells based on the argument that the
11 smaller interfacial area between the donor and acceptor in bilayers results in reduced exciton
12 splitting relative to that in BHJ's, we find that we still get significant exciton harvesting even
13 when the polymer component of the bilayer is optically thick. The facts that exciton splitting in
14 bilayers is still efficient and that segregating the donor and acceptor layers drastically reduces
15 bimolecular recombination²⁹ has allowed us to produce all-solution-processed bilayer PV cells
16 with fill-factors reaching 70% and power conversion efficiencies in excess of 3.5%. Perhaps
17 more importantly, by separating the layers, we have been able to elucidate much of the physics
18 that underlies the operation of polymer-fullerene solar cells. We find that the increase in
19 crystallinity of the PCBM component is largely responsible for the improvement in power
20 conversion efficiency that occurs upon thermal annealing. In addition, we have been able to
21 directly interrogate how the difference between the electron and hole transit times affects the
22 shape of the device current-voltage curve. We find that not only is it critical to balance the
23 electron and hole transit times to produce devices with optimal efficiency, but also that electron
24 transport in the fullerene component is what limits the performance of both P3HT:PCBM bilayer
25 and BHJ solar cells.
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29 Beyond understanding the role of the separate components and interfaces in polymer-
30 fullerene photovoltaics, we also show in this paper that there are additional advantages to being
31 able to form bilayer solar cells cast entirely from solution. First, we demonstrate that there is a
32 set of so-called orthogonal solvents that allows sequential spin-coating of polymer and fullerene
33 layers to produce bilayers: when the right solvent is chosen for spin-casting the fullerene
34 overlayer, there are no changes in the surface morphology of the polymer underlayer, so that
35 there is a sharp, well-defined interface between the two layers. This allows the production of
36 bilayer solar cells with an ease of fabrication that rivals that of BHJ devices and significantly
37 surpasses that of devices in which one of the components must be thermally evaporated under
38 high vacuum. The ability to create solution-processed bilayers also enables the use of organic
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electron acceptors that may not survive thermal evaporation. Second, since the two components of bilayer films are deposited separately, the absorption spectrum and nm-scale morphology of both the polymer and the fullerene layers can be controlled and optimized *independently* using techniques such as thermal or solvent annealing. Finally, depositing the fullerene top layer from solution offers the possibility to achieve efficient exciton dissociation without adversely affecting the mobilities of the carriers being transported in either the polymer or fullerene layers. Thus, we believe that these advantages make the bilayer geometry a serious contender for the future production of large-scale, efficient polymer/fullerene-based solar cells.

II. EXPERIMENTAL

For the production of bilayer photovoltaic devices, there is an inherent difficulty associated with spin-coating sequential layers since most conjugated organic molecules are soluble in similar solvents, so that spin-coating a film on top of an organic underlayer usually results in significant re-dissolution of the bottom layer. Thus, bilayer devices are often produced with one or both layers deposited by thermal evaporation, which limits the device area and restricts the choice of active organic molecules to those that do not decompose during sublimation. One recent alternate approach demonstrated the production P3HT/PCBM bilayer solar cells by transferring a PCBM layer onto pre-coated P3HT substrates using a poly(dimethylsiloxane) (PDMS) stamp, resulting in power conversion efficiencies of ~1.5%.³⁰ Another recent alternate approach involved photo-crosslinking a derivative of P3HT to render it insoluble so that a PCBM overlayer could be spun on top, producing devices with power conversion efficiencies of ~2%.³¹ In contrast, fabrication of fully solution-processed bilayer cells via spin-coating of both components requires finding a set of so-called orthogonal solvents³² such that the solvent used to spin-coat the fullerene overlayers does not affect the morphology of the polymer underlayers. For P3HT/PCBM devices, we find that the common organic solvent dichloromethane (DCM) meets this requirement: PCBM is sufficiently soluble in DCM that it is possible to spin-coat PCBM layers on top of P3HT, and as we show below, P3HT is so sparingly soluble in DCM that there is negligible redissolution of the P3HT underlayer during spin-coating of the PCBM overlayer.

We prepared our P3HT/PCBM bilayer solar cells by starting with pre-patterned indium-doped tin oxide (ITO; TFD sales) substrates that were first cleaned by successive sonication in

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3 detergent solution, de-ionized water, acetone, and finally isopropanol for approximately 10
4 minutes each. The substrates were then blown dry with Ar and briefly treated with an air plasma
5 (200 mTorr, 10 mins) prior to spin-coating a thin (≤ 50 nm)
6 poly(ethylenedioxythiophene):poly(styrenesulfonic acid) (PEDOT:PSS, Baytron P VP A1 4083)
7 layer at 5000 rpm for 60 seconds. The PEDOT:PSS-coated slides were then baked on a
8 digitally-controlled hotplate in a nitrogen atmosphere for 20 minutes at 140 °C. We prepared
9 solutions of regioregular P3HT (Rieke Metals, 90-93% regioregular) in *o*-dichlorobenzene
10 (ODCB) at concentrations of 10, 15, and 20 mg/mL. These solutions were heated to 55 °C for
11 several hours in a nitrogen atmosphere before being cooled to room temperature and spin-cast
12 onto the PEDOT:PSS-coated substrates at 1000 rpm for 90 seconds, producing P3HT films with
13 thicknesses of 50 ± 2 , 80 ± 2 and 115 ± 2 nm, respectively, as measured using a profilometer
14 (Dektak). We then prepared solutions of PCBM (Nano-C) in DCM at concentrations of 5 and 10
15 mg/mL; the 10 mg/mL solution was briefly heated at 40 °C to ensure maximal dissolution. We
16 found the solubility limit of PCBM in DCM to be at or just under 10 mg/mL; thus, only the 10
17 mg/mL solution was filtered prior to spin-coating. We then spin-cast the PCBM solutions at
18 4000 rpm for 10 seconds onto the P3HT films from the previous step, producing PCBM film
19 thicknesses of 22 ± 2 and 34 ± 2 nm, respectively. At a rate of less than 5 Å/s, we then
20 evaporated a cathode consisting of 20 nm of Ca followed by a 20-nm Al protective overlayer
21 onto the completed bilayers through a shadow mask, resulting in active device areas of 6.5 mm².
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37 We measured the photovoltaic performance of our devices in an argon atmosphere using
38 a Keithley 2400 source meter. A xenon arc lamp equipped with a liquid light guide (Oriel) and
39 an AM-1.5 filter was used as the excitation source; the intensity of the incident light on the
40 devices was adjusted to 100 mW/cm², as determined using a calibrated silicon photodiode. We
41 calculated a spectral mismatch factor³³ for our setup of nearly unity. To investigate the effects of
42 thermal annealing on device performance, we placed bilayer devices prior to cathode deposition
43 on a digitally-controlled hotplate at 150 °C for 20 minutes in an Ar atmosphere; the films were
44 covered with a shallow Petri dish during annealing to help ensure uniform heating. At the end of
45 the 20-minute annealing cycle, the films were rapidly cooled by placing them onto a room-
46 temperature metal surface.
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55 We collected photoluminescence (PL) spectra from our bilayer films in air at 22.5° with
56 respect to the excitation beam with the sample positioned at 70° with respect to the excitation
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3 axis. We kept the slit widths and integration times constant for all of our experiments and also
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5 normalized all of the PL spectra displayed by the optical density of the sample at the 530-nm
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7 excitation wavelength and corrected for the detector and monochromator responses so that the
8
9 relative intensities of the different PL spectra presented below are meaningful.

10 Atomic force microscopy (AFM) was carried out using a Nanoscope V Dimension 5000
11 (Veeco Digital Instruments) in ambient conditions. Antimony *n*-doped silicon cantilevers
12 (TESPW, Veeco Probes) with spring constants of 42 N/m, first longitudinal resonance
13 frequencies between 230-410 kHz, and nominal tip radii of 8 nm were employed in tapping
14 mode. Simultaneous height and phase images were acquired and reproduced across multiple
15 samples. To image the P3HT polymer layer after bilayer fabrication, the PCBM overlayer was
16 removed by soaking the bilayer films in cyclohexane for several days in the dark under ambient
17 conditions and then drying the films under vacuum before performing the measurements; as
18 shown below, we found no spectroscopic or AFM evidence for any remaining fullerene
19 following such treatment.
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28 To characterize the PCBM overlayers in our bilayers by X-ray diffraction (XRD), we
29 carried out two-dimensional (2-D) grazing incidence XRD at the Stanford Synchrotron Radiation
30 Light Source on beamline 11-3 with a wavelength of 0.9742 Å. Data was collected on both pure
31 PCBM films spun from DCM onto single-crystal Si substrates and on P3HT/PCBM bilayers.
32 Both samples gave similar diffraction data: diffuse low intensity diffraction for unannealed films
33 and a series of somewhat sharper peaks in films that had been thermally annealed. Because of
34 the very strong P3HT diffraction in the bilayers, however, the PCBM diffraction in the bilayer
35 films was harder to see; thus, we only show the data collected for pure PCBM films below.
36 Because the 2-D PCBM diffraction images did not show any preferred orientation, we radially
37 integrated the data to produce to the one-dimensional patterns shown below, making it easier to
38 clearly visualize the degree of crystallinity in each film.
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49 **III. RESULTS AND DISCUSSION**

50 Although layers of PCBM have been spin-cast from dichloromethane (DCM) onto P3HT
51 films in the past,^{34,35} there has been essentially no work investigating either the quality of the
52 PCBM films produced by spin-coating or the effects of spinning the PCBM top layer onto the
53 P3HT underlayer. Thus, we begin this section with a detailed examination of the morphology of
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3 our spin-cast P3HT/PCBM bilayers. We show that the act of spinning pure DCM solvent has a
4 negligible effect on the P3HT underlayer, and that PCBM layers can be deposited and removed
5 without significantly altering the surface topography of the underlying P3HT film. We also
6 show that the initially-deposited PCBM film is amorphous, but that the PCBM layer becomes
7 partially nanocrystalline upon thermal annealing. We then turn to study the steady-state
8 photophysics of our P3HT-PCBM bilayers, where photoluminescence spectroscopy allows us to
9 investigate the nature of how well PCBM overlayers quench excitons in the P3HT underlayers.
10 We then conclude this section with a detailed investigation of the performance of solar cells
11 based on P3HT/PCBM bilayers.
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22 **A. Physical Characterization of P3HT/PCBM Solution-Processed Bilayers:**

23 One of the real advantages to solution-processed bilayers is that as long as the two layers
24 are distinct and do not significantly intermix, the morphology and other properties of each layer
25 can be studied independently as the processing conditions are varied. In this subsection, we
26 show using a combination of AFM and optical measurements that the P3HT/PCBM solution-
27 processed bilayers we make have a sharp (~1-nm roughness) interface between the P3HT and
28 PCBM components, a conclusion that is also supported by electron microscopy images on cross-
29 sections of our bilayers that are presented in the Supplementary Information.³⁶ We then use a
30 combination of AFM and X-ray diffraction to investigate the effects of thermal annealing on the
31 individual P3HT and PCBM components of the bilayers, and show that the primary effect of
32 annealing is to increase the crystallinity of the PCBM overlayer.
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43 *1. The Sharp Interface of P3HT/PCBM Solution-Processed Bilayers:* Since we are
44 preparing our bilayers by spin-casting the PCBM overlayer from DCM, it is important to ensure
45 that the P3HT underlayer is not dissolved or altered by the DCM solvent used to spin the
46 overlayer. To do this, we started by simply placing a significant amount of P3HT powder into
47 DCM solvent. After stirring for several days, the DCM solution became only faintly colored,
48 and the vast majority of the polymer remained undissolved. The fact that the UV-Visible
49 absorption of the solution was significantly blue-shifted from that of P3HT solutions in good
50 solvents such as *o*-dichlorobenzene (ODCB) indicates that only a small amount of low-molecular
51 weight and/or regiorandom material had dissolved in the DCM. After several washes, we found
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3 that DCM solvent left in contact with P3HT powder remained completely colorless. Thus, we
4 can conclude that with the possible exception of regiorandom impurities or some very low
5 molecular weight material, regioregular P3HT is essentially insoluble in DCM. In the
6 spectroscopic data shown below, we prepared the film samples using the ‘DCM-washed’ P3HT
7 powder; however, we found that the performance of our bilayer solar cells did not depend on
8 whether or not the P3HT powder was ‘washed’ in DCM.
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12 To verify that the use of DCM solvent for deposition of the PCBM overlayer does not
13 affect the morphology of the P3HT underlayer, we present tapping-mode AFM phase images of
14 the initially-deposited P3HT layer as it undergoes the several steps of processing needed to
15 fabricate a bilayer in Figure 1. An image of the surface of a film of pure P3HT cast from ODCB
16 is shown in Figure 1A. The film’s surface is composed of rice-like nanoscale crystallites with an
17 average diameter of 13.8 ± 2.4 nm. To test the effects of spinning an overlayer from a different
18 solvent onto the P3HT film, we spin-cast a drop of pure DCM onto the P3HT film and re-
19 measured the AFM tapping-mode phase image, shown in Figure 1B. The data make it clear that
20 the morphology of the P3HT underlayer is maintained in the presence of DCM; the average
21 P3HT crystallite diameter remains essentially unchanged at 13.2 ± 2.4 nm. Spinning DCM
22 solvent onto the P3HT layer also has a negligible effect on the surface roughness of the P3HT
23 film: the root-mean-square (rms) surface roughness changes from 1.55 nm to 1.47 nm upon
24 addition of the spin-cast DCM drop, a difference that is within the batch-to-batch variations we
25 observed over multiple measurements. Thus, we can conclude that the addition of DCM does
26 not cause any detectable differences in the surface morphology of P3HT films.
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30 To further verify that creating a bilayer by spin-casting a solution of PCBM in DCM on
31 top of P3HT does not alter the morphology of the underlying P3HT film, we fabricated a
32 P3HT/PCBM bilayer and then removed the PCBM overlayer by soaking the bilayer in
33 cyclohexane for several days; a tapping-mode AFM phase image of the P3HT layer that
34 remained following removal of the PCBM overlayer is shown in Figure 1C. As with spin-
35 casting a pure DCM drop, spin-casting a PCBM overlayer and then removing it has little effect
36 on the underlying P3HT surface morphology: the diameter of the crystalline grains are $14.00 \pm$
37 1.8 nm, which is unchanged within the error of the measurement. The surface roughness of the
38 P3HT film, on the other hand, does increase slightly to 2.47 nm upon addition and removal of the
39 PCBM overlayer. A comparison to the surface topography of an as-cast P3HT film that had
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3 been soaked in cyclohexane (without first spin-casting a PCBM overlayer), however, shows a
4 nearly identical topography, and profilometry measurements showed no change in the thickness
5 of the P3HT layer following deposition and removal of the PCBM overlayer. These results
6 suggest that the small increase in surface roughening seen via AFM comes from the removal of
7 the PCBM overlayer and that the act of spin-coating the PCBM overlayer from DCM negligibly
8 changes the underlying P3HT film morphology. This conclusion is also supported by the
9 electron microscopy results presented in the Supplementary Information,³⁶ which show that the
10 thickness and surface roughness of the P3HT layer do not change after overcoating with PCBM
11 to produce a bilayer.
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19 Additional evidence that spin-coating a PCBM overlayer from a DCM solution does not
20 significantly alter the structure of the P3HT film underneath comes in Figure 2, which shows the
21 absorption and photoluminescence (PL) spectra of pure P3HT films before and after spinning a
22 DCM drop on top of the film (panel A) and the spectra from P3HT and P3HT/PCBM bilayer
23 samples after soaking in cyclohexane (panel B). Figure 2A shows that neither the absorption nor
24 the PL of a P3HT film is affected by spin-coating a drop of DCM solvent on top of the P3HT
25 film, a result consistent with the AFM, profilometry and electron microscopy³⁶ data discussed
26 above. Figure 2B shows that after soaking both a pure P3HT film and a P3HT/PCBM bilayer in
27 cyclohexane (CH) for several days, the PL intensity of the former bilayer film is identical within
28 error to that of the pure P3HT film, indicating that our soaking procedure has effectively
29 removed all of the PCBM from the bilayer. We also see that the solvent used to soak the bilayer
30 exhibits the solution-phase spectrum of PCBM. The fact that both the optical and topographic
31 properties of P3HT films are virtually unaffected by spin-coating the PCBM overlayer provides
32 consistent evidence that the P3HT/PCBM interface in our bilayer samples is relatively sharp.
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44 Finally, Figure 3 presents the results of experiments that verify that if interdiffusion of
45 PCBM into the P3HT underlayer had occurred during formation of the bilayer, we would have
46 seen clear signatures of this via AFM. Figure 3A shows a tapping-mode AFM phase image of an
47 80-nm thick 1:1 w/w P3HT:PCBM BHJ film spin-cast from ODCB. The rice-grain-like
48 structure that is seen at the surface of films of pure P3HT (*cf.* Fig. 1) is suppressed since the
49 presence of PCBM in the film breaks up the nanoscale crystallinity of the P3HT. The dark
50 features in this phase image, which correspond to bumps in topography, indicate that PCBM-rich
51 domains are present at the top surface of the BHJ film.³⁷ The fact that the rice-grain-like
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3 structure at the surface of the P3HT underlayers in our bilayers is still clearly visible following
4 deposition and removal of the PCBM overlayer (Fig. 1C) is thus additional evidence that PCBM
5 did not diffuse into the P3HT underlayer. Moreover, Figure 3B shows an AFM phase image of
6 an P3HT:PCBM BHJ film that had had a drop of pure DCM solvent spun on top of it; other than
7 the DCM drop, this BHJ film was prepared identically to the one whose image is shown in Fig.
8 3A. Since PCBM is highly soluble in DCM, the act of spin-coating DCM onto the BHJ blend
9 film removes a significant fraction of the PCBM, as verified by absorption and PL spectroscopy
10 similar to that shown above in Figure 2. The removal of PCBM leaves large craters and valleys
11 in the surrounding P3HT matrix that are clearly visible in the AFM image and result in a ~5-fold
12 increase in the surface roughness of the film. Thus, the data in Figure 3 verify that there would
13 have been obvious topographic signatures if PCBM had interdiffused into the P3HT underlayer
14 during the bilayer fabrication process, so we can be confident that the P3HT/PCBM bilayers we
15 produce have a sharp interface between the two components.
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28 *2. The Effects of Thermal Annealing on the Morphology of P3HT/PCBM Bilayers:* Now
29 that we have established that the P3HT/PCBM interfaces in our solution-processed bilayer
30 samples are sharp, we can use AFM to examine the changes in P3HT surface morphology
31 induced by thermal annealing. If we spin-cast a P3HT film from ODCB and then thermally
32 anneal it, we see that the diameter of the crystalline grains increase slightly to ~17 nm (not
33 shown), a result in agreement with previous reports in the literature.³⁸ If we then spin-coat a
34 PCBM overlayer onto the P3HT film, anneal the full bilayer and then remove the PCBM
35 overlayer by soaking in cyclohexane, we recover an almost identical annealed P3HT surface
36 morphology, as shown by the AFM tapping-mode phase image in Figure 1D. This indicates that
37 other than thermal annealing, none of the processing procedures we employ in the fabrication of
38 our solution-processed bilayers affects either the surface morphology or the intrinsic chain
39 packing in the P3HT underlayer, and that annealing does not promote intermixing of the two
40 components or alter the intrinsic flatness of the P3HT/PCBM interface.
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51 Now that we know that thermal annealing does not affect the layer structure of our
52 solution-processed bilayers, we can turn to investigate the effects of different processing steps on
53 the morphology of the PCBM overlayer. Figure 4A shows an AFM phase image of the top
54 surface of a ~22-nm thick PCBM overlayer that was spin-cast from DCM onto a P3HT
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3 underlayer. The image is almost perfectly homogeneous, indicating that the film is very flat; the
4 rms surface roughness is only 0.46 nm. The lack of discernable features also argues that the
5 PCBM film is completely amorphous: we would expect a partially-crystalline or polycrystalline
6 material to show phase contrast across crystalline domain boundaries due to the difference in
7 force modulus at the edges of the domains, as observed for the P3HT underlayer. In contrast,
8 Figure 4B shows that the surface topography of the PCBM overlayer changes upon thermal
9 annealing, with discernable nanoscale crystallites appearing in the annealed bilayer. The PCBM
10 nanocrystallites are needle-like with an average length of 43.11 ± 18.12 nm and an average width
11 of 8.72 ± 1.63 nm, and sit in a background of largely amorphous material. Thus, we can
12 conclude that spin-cast PCBM layers are highly amorphous, and that thermal annealing induces
13 partial crystallinity in pure PCBM films.
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23 In order to confirm that the topographic features shown in Figure 4B are truly PCBM
24 nanocrystallites, in Figure 4C we show the results of X-ray diffraction (XRD) measurements of
25 both as-cast and thermally-annealed spin-coated PCBM films. The blue dotted curve shows that
26 there is only a weak amorphous diffraction peak observable centered at 13.8 nm^{-1} for the as-cast
27 PCBM film, confirming that the as-cast film is primarily amorphous in nature. Upon thermal
28 annealing, the red solid curve shows three distinct peaks at 12.5, 13.9 and 14.7 nm^{-1} . Based on
29 the widths of these peaks, the Scherrer equation³⁹ gives an estimate for the average diameter of
30 the crystallites of ~ 20 nm, which is in excellent agreement with the average size of the nanoscale
31 features seen via AFM. The exact assignment of the thermally-annealed PCBM diffraction
32 peaks is somewhat difficult to make since there are a number of peaks near these positions in the
33 various PCBM crystal structures obtained from the family of polymorphs reported for PCBM
34 crystals grown from different solvents.⁴⁰ Whatever the precise assignment, the data in Figure 4
35 confirm that spin-cast films of PCBM are amorphous and that thermal annealing increases the
36 degree of PCBM crystallinity.
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50 ***B. The Photophysics of Solution-Processed P3HT/PCBM Bilayers***

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52 With an understanding of the role thermal annealing plays in the structure of our well-
53 defined bilayers, we turn in Figure 5 to examine the photophysics of our bilayer films. The black
54 squares in Fig. 5 show the steady-state PL spectrum of an as-cast 80-nm thick P3HT film spun
55 from ODCB. The relatively pronounced PL shoulder near 720 nm, along with the highly
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3 structured absorption spectrum and red absorption peak near 600 nm seen in Figure 2, have been
4 attributed by others as resulting from a high degree of order of the P3HT chains in the film.⁴¹
5 This is consistent with our choice of ODCB as the solvent used for spin-coating:^{42,43} the slow
6 evaporation kinetics of ODCB give the polymer chains more time to aggregate, in accord with
7 the AFM images shown in Fig. 1 that verify that the P3HT is highly nanocrystalline. The
8 production of such P3HT aggregated lamellar phases by slow solvent evaporation or thermal
9 annealing is advantageous for solar cell operation because more ordered P3HT chains are
10 associated with higher hole mobilities.^{24,44} We note that the absorption spectrum of P3HT films
11 spun from ODCB changes little upon thermal annealing at 150 °C for 20 minutes (not shown),
12 consistent with literature reports:⁴⁵ the slow solvent evaporation of ODCB leaves P3HT films
13 spun from this solvent in an essentially annealed state. We also note that the residual PL from
14 P3HT:PCBM BHJ blend films spun from ODCB does not display the structure indicative of this
15 high degree of organization because the large amounts of PCBM in such films inhibit ordering of
16 the P3HT chains,⁴⁶ consistent with the AFM image shown in Fig. 3A. And as discussed above,
17 we saw no significant changes in either the shape or the intensity of the absorption spectrum of
18 the P3HT layer following deposition of the PCBM overlayer (Fig. 5, inset), either before or after
19 thermal annealing.
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33 The red circles in Figure 5 display the spectroscopy of an as-cast bilayer with an 80-nm
34 thick P3HT underlayer and a ~22-nm-thick PCBM overlayer collected under the same conditions
35 as for the pure P3HT film; the layer thicknesses were verified by profilometry. The absorption
36 spectrum of this bilayer, shown in the inset, fits perfectly to the sum of the individual P3HT and
37 PCBM absorption spectra. The PL data in the main panel show clearly that deposition of the thin
38 PCBM overlayer results in highly quenched polymer fluorescence: comparison of the spectrally-
39 integrated PL from the bilayer and from the P3HT film with no PCBM overlayer yields a
40 quenching ratio of ~90%. We note that steady-state PL quenching measurements are frequently
41 plagued by thin-film interference effects and/or wave-guiding of the fluorescent light.⁴⁷
42 Although we cannot fully eliminate these effects, we believe they have been minimized by
43 choosing a ~20-nm thickness for the PCBM overlayer in these experiments, which is so small
44 compared to the wavelength of the emitted light that the presence of the overlayer should not
45 alter any interference or waveguiding effects in the P3HT underlayer. The ~90% quenching ratio
46 implies a very long effective P3HT exciton quenching length: since the 80-nm thick P3HT
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3 underlayer is photoexcited from the bottom, this result implies an effective quenching length of
4 ~80 nm. This is surprising given that the exciton diffusion length has been estimated by several
5 groups to be in the range of 8-20 nm.^{6,7,48} We will show in an upcoming paper⁴⁹ that this
6 unusually high PL quenching of thick P3HT films by thin PCBM overlayers results from a novel
7 long-range energy transfer mechanism.^{50,51}

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12 The green triangles in Figure 5 show that upon thermal annealing, the PL intensity from
13 P3HT/PCBM bilayer undergoes a slight *increase*, indicating a decrease in exciton quenching
14 efficiency. This result is in direct contrast to the work of Drees *et. al.*, who observed that thermal
15 annealing led to increased quenching of the PL from interdiffused blends of a poly(phenylene
16 vinylene) derivative and C₆₀.⁵² These authors attributed to this increased quenching as resulting
17 from increased mixing of the polymer and fullerene components induced by thermal annealing.
18 The fact that thermally annealing our bilayer samples results in *decreased* exciton quenching
19 suggests that annealing does not promote intermixing of the two components in our solution-
20 processed bilayers.¹⁹ Thus, the behavior of the PL seen in Figure 5, in combination with the data
21 in the previous section, provides consistent evidence that our solution-processed bilayers have a
22 sharp polymer-fullerene interface whether or not they are thermally annealed.
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34 **C. Performance Characteristics of Solution-Processed P3HT/PCBM Bilayer Photovoltaics**

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36 With an understanding of the morphological and photophysical properties of our
37 solution-processed bilayers in hand, we turn next to the behavior of photovoltaic devices in which
38 these bilayers serve as the active medium. We fabricated bilayer devices with differing P3HT
39 and PCBM layer thicknesses and different annealing conditions, the performance characteristics
40 of which are summarized in Table I. The solar cell performance characteristics presented in this
41 table represent average values obtained by testing multiple films with three devices per film. We
42 find an approximately 5% error in J_{sc} and V_{oc} , and roughly a 10% error in FF. Only devices that
43 showed good diodic behavior in the dark were included in the averaging. The injected current
44 characteristics of some of our bilayer devices are shown in the Supplementary Information; if we
45 assume that the current injected is space-charge limited, we extract an average carrier mobility
46 for our devices of $2.3 \times 10^{-5} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$.³⁶
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1. *The Effects of Thermal Annealing on Bilayer Solar Cells:* Figure 6 shows the performance characteristics of ITO/PEDOT:PSS/80-nm P3HT/22-nm PCBM/Ca sandwich-structure bilayer solar cells where the active bilayer was either as-cast (black point-up triangles) or thermally-annealed before deposition of the Ca cathode (filled blue point-down triangles). The data in this Figure and Table I make it clear that thermally annealing completed P3HT/PCBM bilayer solar cells prior to Ca deposition dramatically improves the device performance relative to as-cast devices: annealing causes an increase in J_{sc} of ~23% and in FF of ~74% relative to the as-cast device. In addition, annealing produces an increase in the V_{oc} of these bilayer cells by nearly 15%, which is surprising given that annealing has been shown to have relatively little effect on the V_{oc} of BHJ cells fabricated from these same materials.^{20,53} We are confident that these annealing-induced changes in the performance of the bilayer cells do not result from changes in the morphology of the P3HT layer for two reasons. First, we saw very little change in the P3HT absorption spectrum or surface topography upon annealing, suggesting that thermal annealing does little to change the degree of chain ordering in the highly organized P3HT layer that was cast from ODCB.⁴⁵ Second, we also prepared bilayer solar cells in which we annealed the P3HT underlayer *before* spin-coating the PCBM overlayer, and we found that the performance of these devices *decreased* relative to those in which neither layer was annealed, as shown by the open blue point-down triangles in Figure 6. Thus, the thermal annealing-induced improvement in performance of our bilayer devices must be due to changes that occur within the fullerene layer.

We believe that the performance improvements that occur in bilayer devices that were thermally annealed result primarily from the annealing-induced increase in crystallinity of the fullerene overlayer (*cf.* Figure 4). This is because the morphology of the as-cast fullerene layer is amorphous, a consequence of kinetic trapping of the inter-fullerene packing structure due to the rapid evaporation of DCM during spin-coating. The amorphous nature of this layer results in a large degree of positional and energetic disorder, which is correlated with slow electron hopping rates and thus poor electron mobility. The partial crystallization of PCBM that occurs upon annealing removes some of this disorder, producing an increased electron mobility and hence an increased photocurrent. The increased electron mobility also decreases the average transit time (t_{tr}) for the electrons to traverse the fullerene layer.⁵⁴ As discussed further below, we

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3 believe that the annealing-induced improvement in fill-factor is a direct consequence of an
4 improved balance of the carrier transit times for the electrons and holes in the bilayer device.
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8 *2. The Effects of Layer Thickness on the Performance of Bilayer Solar Cells:* The data in the
9 previous section argue strongly that electron mobility in the PCBM layer plays a significant role
10 in determining the shape of the current-voltage curve of solution-processed P3HT/PCBM bilayer
11 solar cells. To better understand the roles of electron mobility and perhaps most importantly the
12 balance of carrier transit times on device performance, we have measured the operating
13 characteristics of bilayer solar cells as a function of the thickness of the individual P3HT and
14 PCBM layers, as summarized in Figure 7 and Table I. Because all of the carriers in bilayer
15 photovoltaics are generated within a few nanometers of the donor-acceptor interface, our ability
16 to vary the thickness of the individual layers allows us to study how changing the transit time of
17 each carrier affects solar cell performance without significantly changing the bulk mobility of
18 either component or the nature of the interfaces. This is something that is not possible with BHJ
19 devices, where changes in the nanometer-scale morphology of the interpenetrating network of
20 the two components with processing conditions^{1,4} makes it impossible to determine the distance
21 carriers must traverse to exit the device or to keep the mobility of one carrier virtually fixed
22 while varying the mobility of the other carrier via thermal annealing.
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35 Figure 7A shows the AM-1.5-illuminated current-voltage characteristics of P3HT/PCBM
36 bilayer solar cells annealed before deposition of the Ca cathode with three different P3HT layer
37 thicknesses: 50 nm (green diamonds); 80 nm (blue triangles) and 115 nm (red squares). The
38 PCBM layer thickness was held fixed at 22 nm for all of these devices. The data show that the
39 photovoltaic power conversion efficiency does not change monotonically with P3HT layer
40 thickness: the efficiency of the devices with 80-nm thick P3HT layers is higher than those of the
41 devices with thicker and thinner P3HT layers. We believe that this P3HT thickness dependence
42 of the device performance results from a trade-off between improved optical absorption and
43 misbalanced carrier transit times⁵⁴ as the thickness of the P3HT layer is increased. The devices
44 with 50-nm thick P3HT layers have the highest fill-factor, suggesting that the carrier transit
45 times in these cells are the closest to being optimally balanced. The overall efficiency of these
46 devices is thus likely limited only by photon harvesting, since the thin 50-nm polymer layer has
47 an optical density at the P3HT absorption maximum of only ~0.35. When the thickness of the
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3 P3HT layer is increased to 80 nm, the J_{sc} increases because the larger absorption by the thicker
4 polymer layer leads to the creation of additional carriers. The fill-factor of the 80-nm thick
5 P3HT devices is slightly lower than those of the 50-nm devices, however, suggesting that the
6 increased hole transit time associated with the thicker P3HT layer is becoming out of balance
7 with the smaller electron transit time in the thin PCBM layer. When the device thickness is
8 further increased to 115 nm, even though the absorption is further increased, the hole transit time
9 becomes so out of balance with the electron transit time that the FF decreases considerably and
10 the J_{sc} is significantly reduced. Another possible explanation for the poor performance of this
11 device is that the 115-nm-thick polymer layer has become much larger than the effective
12 quenching length of P3HT, limiting exciton harvesting and thus device efficiency. The PL
13 quenching data in Figure 5, however, suggests that exciton harvesting is not a problem in our
14 bilayer samples.⁵¹ We will show next that it is indeed misbalanced carrier transit times that
15 limits the performance of bilayer devices with thick P3HT layers.

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If misbalanced carrier transit times are really the main culprit limiting the fill-factor in P3HT/PCBM bilayer solar cells with thick P3HT layers, then it should be possible to improve devices with thick P3HT layers by increasing the thickness of the PCBM layer to improve the balance. Figure 7B shows the photovoltaic performance of a set of P3HT/PCBM bilayer solar cells fabricated under identical conditions to those in Fig. 7A except that the PCBM overlayer thickness was increased from 22 to 34 nm. The simple act of increasing the PCBM layer thickness leads to a completely different trend of the power conversion efficiency with P3HT layer thickness: with the 34-nm thick PCBM overlayer, it is the devices made with 115-nm thick P3HT layers (solid red squares) that have by far the best power conversion efficiency, despite the fact that one might expect there to be poor diffusion of the P3HT excitons to the PCBM interface through such a thick layer of P3HT.⁶ In fact, these devices have a higher J_{sc} than any of the devices with the 22-nm thick PCBM layer shown in Fig. 7A, including the devices with 80-nm thick P3HT layers (solid blue triangles), and have power conversion efficiencies that exceed 3.5%. The fact that the 115-nm P3HT/34-nm PCBM bilayer devices have a higher current, similar FF and higher efficiency than comparable devices in which both layers are thinner indicates that it is *balancing* the carrier transient times -- not simply minimizing them -- that is important for the optimization of polymer-fullerene solar cells. The devices in Fig. 7B with thinner P3HT layers thus suffer from both reduced absorption and a more misbalanced set of

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3 carrier transit times, explaining their lower net power conversion efficiency.⁵⁵ We show in the
4 Supplementary Information that the effective mobility of the carriers injected into bilayers in the
5 dark is also improved when the carrier transit times are balanced, even when the total device
6 thickness has to be increased to achieve this balance.³⁶
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10 Figure 7C and Table I summarize how both the fill-factor (filled symbols) and the short-
11 circuit current (open symbols) of our bilayer devices vary with P3HT thickness for bilayers with
12 both 22-nm (blue squares) and 34-nm (red circles) PCBM overlayers. Since the open circuit
13 voltage is nearly the same for all of these devices, the device efficiencies are proportional to the
14 product of the short-circuit current and the fill-factor (Table I). This figure shows clearly how
15 the fill-factor reaches a maximum when the P3HT thickness is chosen to match the carrier transit
16 times in the two layers, as discussed above. But perhaps the most striking feature of the data in
17 Fig. 7C is that for the devices with the 34-nm-thick PCBM overlayer, the short-circuit current
18 continues to increase with P3HT layer thickness, even for P3HT layers as thick as 150 nm. This
19 again indicates that exciton harvesting is not what limits the performance of our bilayer devices,
20 and suggests that we could make even more efficient bilayer devices if we were able to spin-coat
21 PCBM layers that were thicker than 34 nm.
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32 The other important feature of the data in Figure 7 is that for a given PCBM overlayer
33 thickness, the optimally efficient bilayer solar cell is the one whose P3HT layer is ~4 times
34 thicker than the PCBM layer. Since the distance the holes must travel to be extracted is four
35 times that of the electrons, this strongly indicates that the mobility of the electrons in the PCBM
36 layer is smaller than that of the holes in the P3HT layer: in other words, it is the conduction
37 and/or extraction of *electrons* that ultimately limits the performance of these devices. We
38 believe that the mobility of electrons in the PCBM layer is the limiting factor because bilayer
39 devices with annealed PCBM layers work better than bilayer devices with as-cast PCBM layers,
40 independent of the state of the P3HT layer (Fig. 6, Table I). We also have argued in previous
41 work that it is electron conduction among the fullerene component of P3HT:PCBM BHJ devices
42 that is performance limiting;¹⁹ those arguments are reinforced by the data given here. In other
43 words, the BHJ geometry forces electrons to travel a longer, more tortuous path on a PCBM
44 network that is much less crystalline than is the case in our annealed bilayer devices. Because
45 the BHJ geometry involves an interpenetrating network, the fullerene thickness cannot be
46 adjusted independently of the polymer thickness as it can in the bilayer geometry. Thus, these
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3 results imply that the most fruitful avenues for investigation in how to further improve polymer-
4 fullerene solar cells lie in improving carrier mobility in the fullerene component of the devices,
5 not the polymer.⁵⁶
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10 11 12 **IV. CONCLUSIONS**

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14 In summary, we have prepared fully solution-cast P3HT:PCBM bilayer solar cells with
15 well-defined planar interfaces and found that their photovoltaic performance rivals that of BHJ
16 devices fabricated from the same materials. We found that ODCB and DCM serve as an
17 excellent pair of orthogonal solvents for the sequential spin-coating of regioregular P3HT and
18 PCBM layers, respectively, and that spinning the PCBM overlayer has essentially no effect on
19 the morphology of the P3HT underlayer. The ease of solution processing not only provides a
20 general method for fabricating bilayer devices from materials that do not survive thermal
21 deposition but also allows the performance of each layer to be optimized (*e.g.*, via, thermal
22 annealing or the use of solvent additives) individually, something that is not possible for devices
23 based on the BHJ architecture.
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32 Our choice to fabricate bilayer P3HT:PCBM devices is based on the fact that their
33 geometry is much simpler than the complex nanometer-scale architecture inherent in BHJ
34 devices. In particular, the nature of the interpenetrating network in BHJ devices is quite
35 sensitive to the degree of mixing of the two components in the blend film, which in turn depends
36 critically on the processing conditions. This has made it challenging to fully understand the
37 changes in photovoltaic performance observed upon the thermal annealing of BHJ devices since
38 annealing simultaneously changes the mobilities of both carriers, likely in opposite directions.¹⁹
39 Annealing also changes the effective carrier pathlengths and transit times, as well as the nature of
40 any extraction barriers at the organic/electrode interfaces. By studying bilayers with a
41 controllably-fixed geometry, we have been able to isolate the effect of misbalancing the carrier
42 transit times on device performance.
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52 One of the advantages of the bilayer geometry is that the stepwise deposition of the
53 bottom and top layers allows the distance each of the carriers traverses to be controlled
54 independently without simultaneously changing either the carrier mobility or the nature of any of
55 the interfaces. We found that the highest fill-factors in bilayer devices are achieved not by
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3 minimizing the electron and hole transit times but by balancing them. The idea of *increasing* the
4 thickness of the active layer to improve device performance is counterintuitive for BHJs: the
5 thicker the BHJ, the longer it takes carriers to escape the active layer and thus the more likely it
6 is to lose significant numbers of carriers to bimolecular recombination.²⁹ For bilayers, however,
7 bimolecular recombination is not a significant issue, and thus the thickness of the active layers
8 can be greatly increased as long as the balance in carrier transit times is maintained. When the
9 carrier transit times are balanced, we can produce devices with fill-factors of 70% and AM-1.5
10 power conversion efficiencies in excess of 3.5%.
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12 We close by highlighting that the bilayer devices with the highest efficiencies contain a
13 P3HT underlayer that is roughly four times thicker than that of the PCBM overlayer, which
14 implies that it is the conduction and extraction of electrons through the fullerene layer that limits
15 the performance of both bilayer *and* BHJ devices based on these materials: since the path that
16 electrons must traverse in BHJ films is much more tortuous and less crystalline than that in the
17 thin fullerene overlayer in a bilayer, it makes sense that electron transport on the PCBM
18 component is what limits the performance of BHJ solar cells.¹⁹ This argument is also supported
19 by the fact that improved crystallinity of the PCBM overlayer is responsible for the
20 improvements in bilayer device performance upon thermal annealing. Thus, we believe that the
21 greatest potential for improving the performance of polymer-based photovoltaics lies in using
22 electron acceptors with higher charge carrier mobilities and finding a suitable way to optimize
23 electron extraction at the cathode. We also note that the most efficient bilayer devices described
24 here had P3HT layers that were ~115 nm thick, an order of magnitude larger than the canonical
25 value assumed for the exciton diffusion length in P3HT.⁶ Given that exciton harvesting in
26 bilayers appears to be more efficient than previously thought,⁴⁹ we also believe that the bilayer
27 geometry offers a better means to accomplish these goals than the kinetically-trapped nanoscale
28 complexity inherent in BHJs.
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Table I: Performance Parameters of ITO/PEDOT:PSS/P3HT/PCBM/Ca/Al Bilayer Solar Cells Under AM-1.5 Illumination

Processing of Solar Cell Active Bilayer	P3HT ^a (nm)	PCBM ^a (nm)	J_{sc} (mA cm ⁻²)	V_{oc} (V)	FF (%)	PCE ^b (%)
annealed	50	22	6.9	0.66	68	3.1
as-cast	80	22	6.1	0.58	39	1.4
annealed P3HT only ^c	80	22	5.4	0.38	38	0.8
annealed	80	22	7.5	0.66	68	3.4
annealed	115	22	6.2	0.66	53	2.2
annealed	125	22	6.9	0.67	54	2.5
annealed	140	22	6.0	0.66	45	1.8
annealed	155	22	4.6	0.66	40	1.2
annealed	50	34	3.3	0.63	52	1.1
annealed	80	34	5.9	0.63	68	2.5
annealed	115	34	8.2	0.63	66	3.5
annealed	125	34	8.3	0.64	64	3.4
annealed	140	34	8.6	0.64	63	3.5
annealed	155	34	8.7	0.65	61	3.4

^a Thickness of the spin-cast layer

^b Power conversion efficiency

^c P3HT layer was annealed before deposition of the PCBM overlayer

Figure Captions:

Figure 1: 1 μm \times 1 μm AFM tapping-mode phase images of: (A) an-cast P3HT film. The nanocrystalline domains have an average diameter of ~ 14 nm and the rms surface roughness is 1.55 nm. (B) an as-cast P3HT film onto which a drop of dichloromethane (DCM) solvent has been spun. The size of the nanocrystalline domains and surface roughness are identical within the error to the as-cast film shown in panel A. (C) an as-cast P3HT film onto which a PCBM layer had been spun from DCM and then subsequently removed by soaking the bilayer in cyclohexane. The size of the P3HT nanocrystalline domains is identical within the noise to the films shown in panels A and B. (D) a P3HT film onto which a PCBM layer had been spun from DCM with the bilayer annealed at 150 $^{\circ}\text{C}$ for 20 minutes following removal of the PCBM overlayer by soaking in cyclohexane. The annealing process increases the average size of the P3HT nanocrystallites to ~ 17 nm and the rms surface roughness to 2.67 nm. The scale bar in each panel is 500 nm.

Figure 2: Steady-state absorption spectra (solid symbols, left axes) and photoluminescence spectra (open symbols, right axes) of P3HT films at various processing stages in the formation of P3HT/PCBM bilayers. (A) Steady-state spectra of an 80-nm thick P3HT film as-cast from ODCB (green stars), and the same film onto which a drop of DCM solvent had been spun (purple hexagons). The P3HT powder was treated with DCM to ensure complete removal of a small amount of oligomeric and regiorandom segments. (B) Steady-state spectra of an 80-nm thick P3HT film spin-cast from ODCB that had been soaked in cyclohexane (black squares), and a 80-nm P3HT/22-nm PCBM bilayer fabricated as described in the text that had also been soaked in cyclohexane for the same amount of time (red circles). The solid blue squares show the absorption spectrum of the cyclohexane solution that had been used to soak the bilayer; the absorption spectrum of this solution exactly matches that of solution-phase PCBM.

Figure 3: 1 μm \times 1 μm AFM tapping-mode phase images of: (A) An 80-nm thick 1:1 w/w P3HT:PCBM BHJ blend film spin-cast from ODCB. The nanocrystalline P3HT domains seen in Fig. 1 are suppressed by the presence of PCBM at the top surface of the film, which breaks up the order of the P3HT chains. The large black features, which correspond to bumps in topography, result from PCBM-rich domains. (B) The same BHJ film whose AFM image is

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3 shown in (A) onto which a drop of pure DCM solvent had been spun. The new features and ~5-
4 fold increase in surface roughness result from the removal of PCBM from the blend film by the
5 DCM solvent, leaving behind an open P3HT matrix. These results show clearly that if the
6 PCBM in bilayer structures had interdiffused into the P3HT underlayer, it would have resulted in
7 obvious signatures via AFM.
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13 **Figure 4:** (A) $1\ \mu\text{m} \times 1\ \mu\text{m}$ AFM tapping-mode phase image of an as-cast PCBM overlayer
14 spin-cast from dichloromethane (DCM) on top of a P3HT film. The lack of phase contrast and
15 0.46-nm rms surface roughness indicates that the film is amorphous. (B) $1\ \mu\text{m} \times 1\ \mu\text{m}$ AFM
16 tapping-mode phase image of a PCBM overlayer spin-cast from DCM on top of a P3HT film
17 after the bilayer had been thermally annealed at 150 °C for 20 minutes. Annealing produces
18 PCBM nanocrystallites with an average diameter of ~26 nm and increases the rms surface
19 roughness of the film to 2.34 nm. (C) X-ray diffraction of PCBM films spin-cast from DCM
20 both before (blue dashed curve) and after (red solid curve) thermal annealing. The appearance of
21 the diffraction peaks after annealing is consistent with the observation of PCBM nanocrystallites
22 in panel B; the width of these peaks corresponds to an average crystalline domain size of ~20
23 nm, also in excellent agreement with the AFM results in panel B.
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34 **Figure 5:** Steady-state photoluminescence spectra following 530-nm excitation for an 80-nm
35 thick P3HT film spin-cast from ODCB that had had a drop of pure DCM solvent spun on top of
36 it (black squares), a solution-processed bilayer with an identical P3HT underlayer and a 22-nm
37 PCBM overlayer spin-cast from DCM (red circles), and the same bilayer following thermal
38 annealing (green triangles). The spectrally-integrated PL quenching of the as-cast P3HT/DCM
39 film upon addition of the PCBM overlayer is ~90%. The inset shows the absorption spectrum of
40 the bilayer prior to thermal annealing.
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48 **Figure 6:** Current density versus applied bias for ITO/PEDOT:PSS/P3HT/PCBM/Ca/Al
49 solution-processed bilayer solar cells under AM-1.5 illumination, where the active bilayer is
50 either an as-cast ~80-nm thick P3HT film spin-cast from ODCB with a 22-nm thick PCBM
51 overlayer spun from DCM (solid black point-up triangles), or an ~80-nm thick P3HT film with a
52 DCM-spun ~22-nm PCBM overlayer that had been thermally annealed at 150 °C for 20 minutes
53 prior to deposition of the cathode (solid blue point-down triangles). For comparison, the open
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3 blue point-down triangles show the J - V characteristics of an identical bilayer device where the
4 P3HT layer was annealed prior to deposition of both the PCBM overlayer and the cathode.
5 Details of the device performance parameters are summarized in Table I.
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11 **Figure 7:** (A) Current density versus applied bias for thermally-annealed
12 ITO/PEDOT:PSS/P3HT/PCBM/Ca/Al solution-processed bilayer solar cells under AM-1.5
13 illumination with a 22-nm thick PCBM overlayer for different thicknesses of the P3HT
14 underlayer spun from ODCB: 50 nm (green diamonds), 80 nm (blue triangles) and 115 nm (red
15 squares). (B) The same as panel (A), but for devices with a 34-nm thick PCBM overlayer spun
16 from DCM. (C) Bilayer solar cell performance factors as a function of P3HT layer thickness.
17 The squares show the performance of devices with a 22-nm thick PCBM layer, while the circles
18 show the performance of devices with a 34-nm thick PCBM layer. Solid symbols denote the
19 device fill-factor (left axis), while open symbols denote the device short-circuit current (right
20 axis). Lines connect the data points and are meant to guide the eye. Details of the device
21 performance parameters are summarized in Table I.
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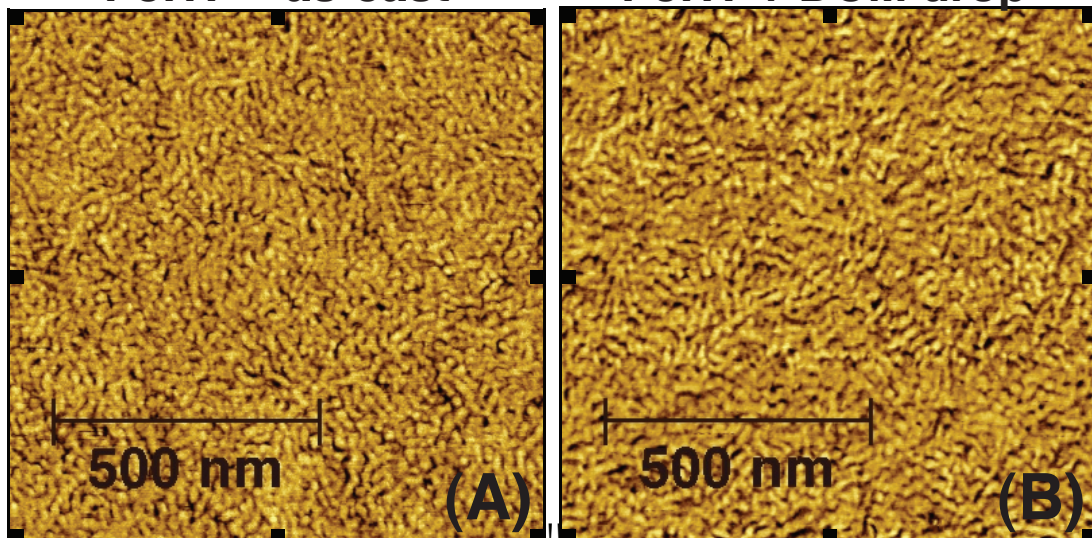
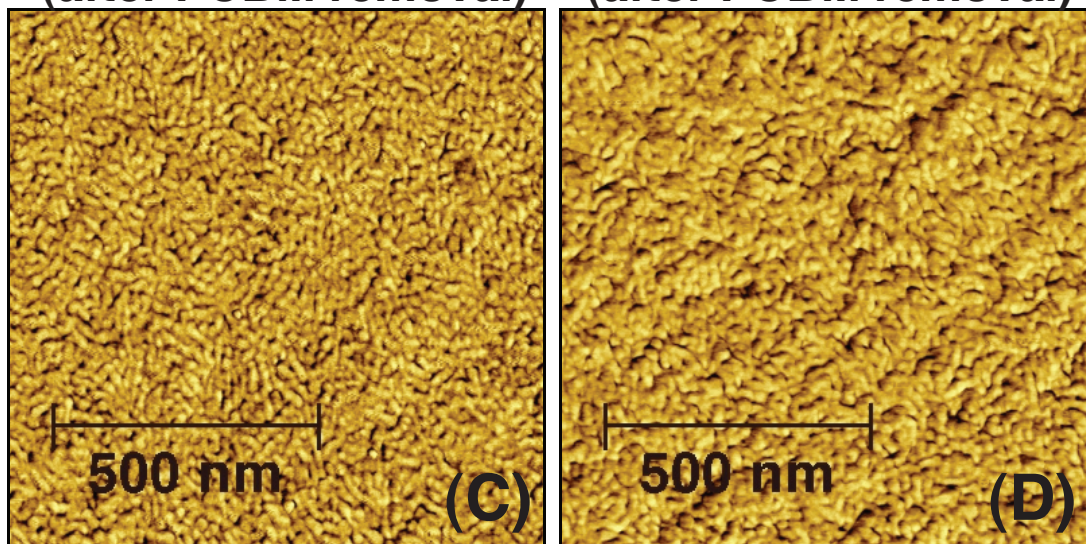
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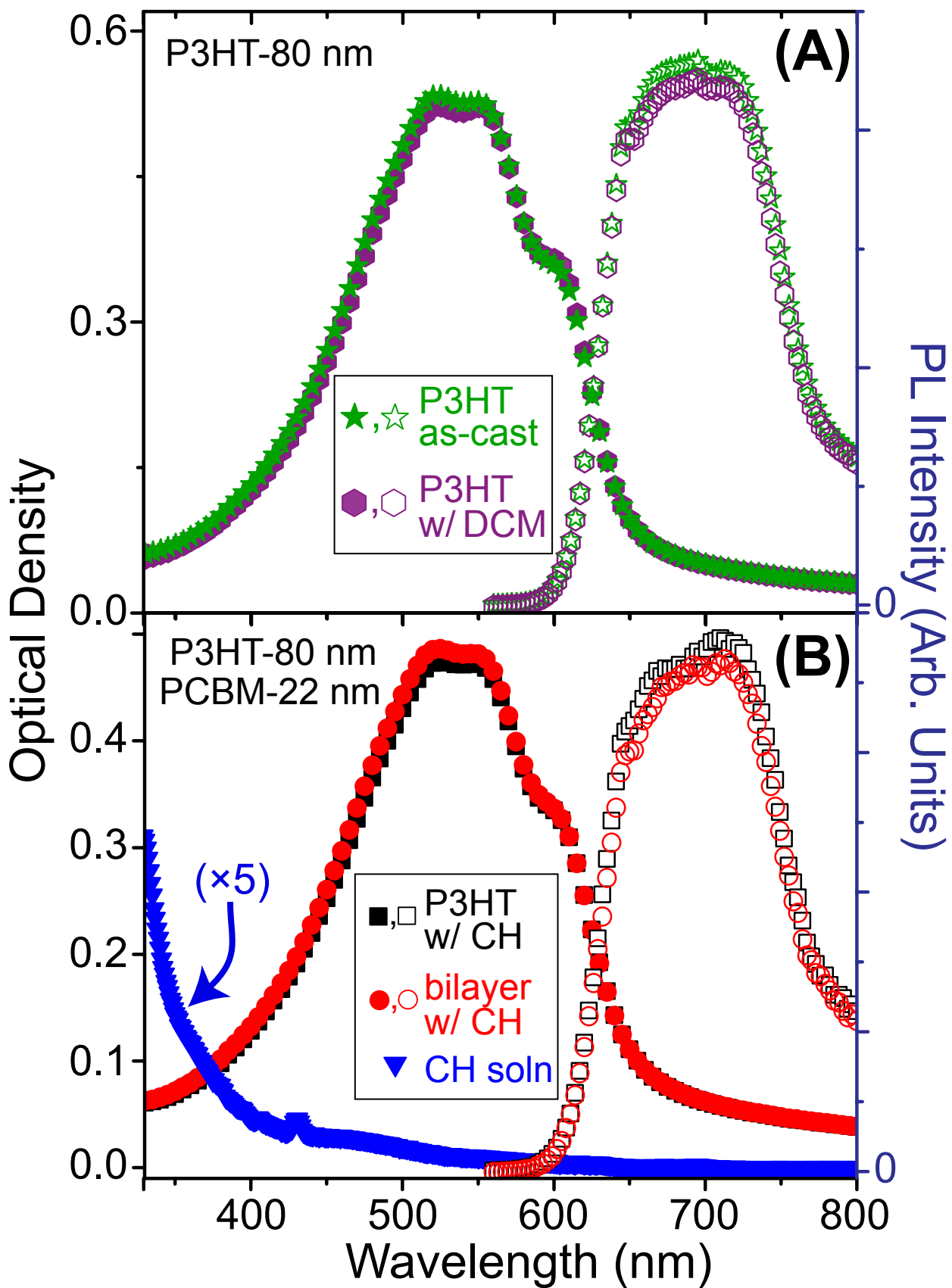
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- ⁵⁵ We note that minimizing the carrier transit times is likely to be much more important in BHJ devices, where the strong degree of mixing of the two components allows recombination to a significant role the longer carriers take to escape. Recombination is much less of an issue in

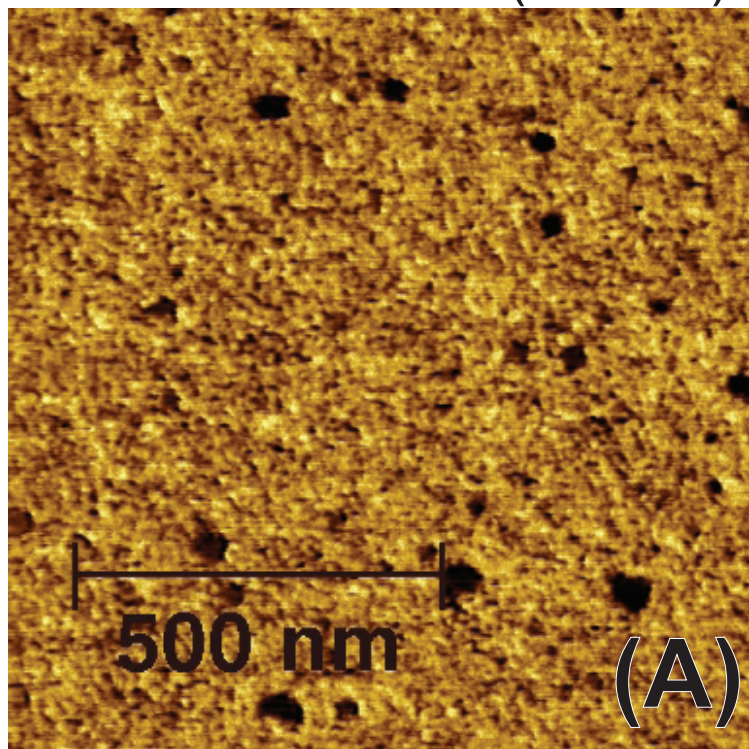
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4 bilayers, since oppositely charged carriers never re-encounter each other once they leave the
5 P3HT/PCBM interface.
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P3HT -- as-cast**P3HT + DCM drop****P3HT -- as-cast
(after PCBM removal)****P3HT -- annealed
(after PCBM removal)**

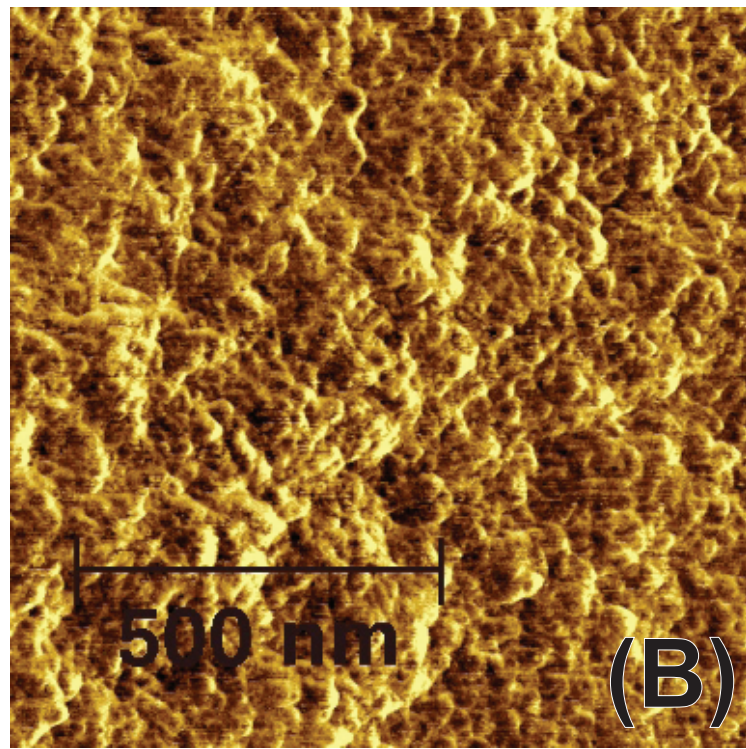


P3HT:PCBM BHJ (as-cast)



surface roughness = 1.5 nm

P3HT:PCBM BHJ + DCM



surface roughness = 7 nm

PCBM -- as-cast

PCBM -- annealed

